

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 20, 2025

IGI Report Number

LG741511196

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

9.47 X 6.39 X 4.62 MM

GRADING RESULTS

Carat Weight

2.83 CARATS

Color Grade

D

Clarity Grade

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

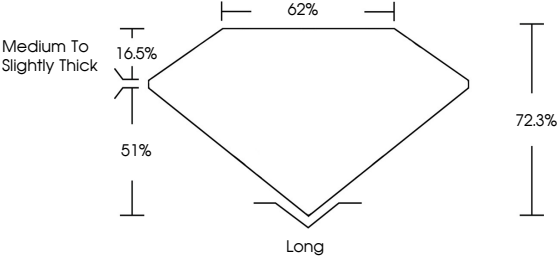
Inscription(s)

 LG741511196

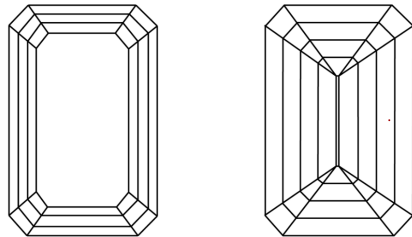
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS



Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Carat Weight

2.83 CARATS

Color Grade

D

Clarity Grade

VVS 1

Depth

51%

Table

16.5%

Girdle

Medium to Slightly Thick

Culet

Long

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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